

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Richard Longstreth White	01/20/2005
RECEIVING PARTY DATA	
Name:	HITACHI GLOBAL STORAGE TECHNOLOGIES NETHERLANDS B.V.
Street Address:	Locatellikade 1, Parnassustoren
Internal Address:	1076 AZ
City:	Amsterdam
State/Country:	NETHERLANDS
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	11040376
CORRESPONDENCE DATA	
Fax Number:	(801)531-1929
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Phone:	801-994-4646
Email:	HBabb@utahpatentlaw.com
Correspondent Name:	Brian C. Kunzler
Address Line 1:	8 East Broadway, Suite 600
Address Line 4:	Salt Lake City, UTAH 84111
NAME OF SUBMITTER:	Brian C. Kunzler
Total Attachments: 1 source=Assignment#page1.tif	

CH \$40.00 11040376

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PATENT
REEL: 015750 FRAME: 0606

ASSIGNMENT

Whereas I/we

INVENTOR CITY
COUNTY STATE

(1) Richard Longstreth White
County of Santa Clara

City of Los Altos
State of California

have invented certain improvements in

TITLE

METHOD AND SYSTEM FOR MEASURING OVERCOAT LAYER THICKNESS ON A THIN FILM DISK

and executed, respectively, a United States patent application therefor on the following date(s):

DATE(S) THE
INVENTOR(S)
SIGNED THE
DECLARATION

(1) 1/20/2005

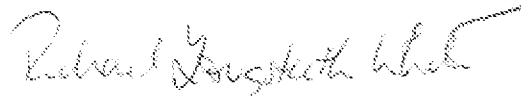
Whereas, HITACHI GLOBAL STORAGE TECHNOLOGIES NETHERLANDS B.V., having a place of business at Locatellikade 1, Parnassustoren, 1076 AZ Amsterdam, The Netherlands (hereinafter called HITACHI), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefore;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we, the above named, hereby sell, assign, and transfer to HITACHI, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to HITACHI, its successors and assigns; and we hereby agree that HITACHI may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by HITACHI.

Signed:

CITY
DATE

(1) at San Jose
on 1/20, 2004


Richard Longstreth White

PATENT